

## REFLECTING MICROOPTICAL SYSTEM

This disclosure is based upon, and claims priority from, Japanese Patent Application No. 10-333940, filed November 25, 1999, the contents of which are incorporated herein by reference.

### 5     **Field of the Invention**

The present invention relates to a reflecting microoptical system, for example of the type used in a small-size optical pickup, particularly a high-density optical recording pickup.

### **Background of the Invention**

10           Methods have conventionally been proposed for increasing the numerical aperture (NA) of an objective lens in order to increase the information recording density of optical recording media, such as optical disks, optical cards, etc. One such method is to dispose an SIL (solid immersion lens) between the optical recording medium and the objective lens. However, the addition of an SIL to an  
15           optical pickup increases the weight of the read/write head, which must be controlled to move at high speed. To avoid this problem, a method using an SIM (solid immersion mirror) has been proposed (ODF '98, Tokyo, June 16, 1998, "Objective Lenses for DVD & Near Field Optical Disk Pick-up"). The SIM is a catadioptric system in which the luminous flux incident on a central portion is  
20           reflected at a peripheral portion.

          Since the SIM is formed of surfaces defined by a discontinuous expression, the decentration error of each surface is large and its configuration is complicated. Therefore, it is extremely difficult to form the SIM by glass molding using a high-refractive-index glass material. When the SIM is used in a case where uniform  
25           light is incident, while the numerical aperture can be increased (the angle with respect to the light spot can be increased), a sufficient light quantity cannot be obtained because only a central part of the luminous flux can be used.

### **Summary of the Invention**

The present invention is directed to such a situation, and an object thereof is to provide a reflecting microoptical system that is formed of only two optical surfaces having a continuous configuration, and has a simple configuration suitable for glass molding. Different combinations of convex, planar and concave surfaces are disclosed for the two optical surfaces, to provide different advantageous properties. In preferred embodiments of the invention, at least one, and in some cases both, of the optical surfaces have an aspherical shape to correct for aberrations.

### **Brief Description of the Drawings**

Specific embodiments of the invention will be described hereinafter with reference to the examples illustrated in the accompanying figures, in which:

Figure 1 shows the optical path of a first embodiment of a reflecting microoptical system in accordance with the present invention;

Figure 2 shows the aberration of the first embodiment;

Figure 3 shows the optical path of a second embodiment;

Figure 4 shows the aberration of the second embodiment;

Figure 5 shows the optical path of a third embodiment;

Figure 6 shows the aberration of the third embodiment;

Figure 7 shows the optical path of a fourth embodiment;

Figure 8 shows the aberration of the fourth embodiment;

Figure 9 shows the optical path of a fifth embodiment;

Figure 10 shows the aberration of the fifth embodiment;

Figure 11 shows the optical path of a sixth embodiment;

Figure 12 shows the aberration of the sixth embodiment;

Figure 13 shows the optical path of a seventh embodiment;

Figure 14 shows the aberration of the seventh embodiment;

Figure 15 shows the optical path of an eighth embodiment;

Figure 16 shows the aberration of the eighth embodiment;  
Figure 17 shows the optical path of a ninth embodiment;  
Figure 18 shows the aberration of the ninth embodiment;  
Figure 19 is an explanatory view showing the regions of a totally reflecting  
5 coating used in the embodiments.

### **Detailed Description**

Hereinafter, reflecting microoptical systems embodying the present  
invention will be described with reference to the drawings. Figures 1, 3, 5, 7, 9,  
11, 13, 15 and 17 show the lens constructions of nine embodiments of the  
10 invention which can be used as pickup lenses. In the figures, the surfaces marked  
with  $S_i$  ( $i=1, 2$ ) are the  $i$ -th surfaces counted from the long conjugate distance  
side, and the surfaces  $S_i$  marked with asterisks are aspherical. With reference to  
Figure 19, in all of these embodiments, in order for the incident light to be imaged  
on a second surface ( $S_2$ ) after being reflected twice within the lens, a totally  
15 reflecting coating is applied in the vicinity of the optical axis (AX) of a first  
surface ( $S_1$ ) and a peripheral zone of the second surface ( $S_2$ ), as indicated by the  
hatched areas. Since the embodiments are systems in which the light emitted from  
the light source is applied to an optical recording medium, the "long conjugate  
distance side" is the "light source side".

20 The first and the second embodiments of Figures 1 and 3 are biconvex  
pickup lenses in which the first surface ( $S_1$ ) and the second surface ( $S_2$ ) are both  
aspherical. In the second embodiment, the numerical aperture is greater than that  
of the first embodiment, and the numerical aperture in the medium exceeds 1.  
This means that a marginal ray is totally reflected at the second surface ( $S_2$ ) and  
25 the evanescent light in close proximity to the second surface ( $S_2$ ) is also used for  
optical recording. The third embodiment of Figure 5 is a biconvex pickup lens in  
which only the first surface ( $S_1$ ) is aspherical. The fourth embodiment of Figure 7  
is a biconvex pickup lens in which only the second surface ( $S_2$ ) is aspherical.

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A structure is desirable in which, as in the first to the fourth embodiments, the first surface (S1) is convex to the long conjugate distance side and the second surface (S2) is convex to the side opposite to the long conjugate distance side. The luminous flux passing through a peripheral part of the first surface (S1) is reflected at a peripheral part of the second surface (S2), is again reflected at a central part of the first surface (S1) and is imaged in the vicinity of the vertex of the second surface (S2). Since the configurations of the first to the fourth embodiments are close to those of biconvex single lenses, like in normal single lenses, aberrations can be reliably corrected with a slight aspherical amount by increasing the curvature of the first surface (S1).

By using an aspherical surface for one of the surfaces, as in the third and the fourth embodiments, performance with a wavefront aberration of  $\lambda/8$  or less can be realized. Decreasing the aberration correction burden on each surface by using aspherical surfaces for both of the surfaces, as in the first and the second embodiments, permits the numerical aperture to be increased. Therefore, by decreasing the beam spot diameter, higher-density optical recording can be handled.

The fifth embodiment of Figure 9 is a pickup lens in which the first surface (S1) is a convex aspherical surface and the second surface (S2) is a plane surface, in order of disposal from the long conjugate distance side. The luminous flux passing through a peripheral part of the first surface (S1) is reflected at a peripheral part of the second surface (S2), is again reflected at a central part of the first surface (S1), and is imaged in the vicinity of the vertex of the second surface (S2).

The sixth embodiment of Figure 11 is a pickup lens in which the first surface (S1) is a plane surface and the second surface (S2) is a convex aspherical surface. The seventh embodiment of Figure 13 is a pickup lens in which the first surface (S1) is a plane surface and a second surface (S2) is a paraboloid of revolution. In the structures of the sixth and the seventh embodiments, where the

first surface (S1) is a plane surface and the second surface (S2) is convex to the side opposite to the long conjugate distance side in order of disposal from the long conjugate distance side, the luminous flux passing through a peripheral part of the first surface (S1) is reflected at a peripheral part of the second surface (S2), is  
5 again reflected at a central part of the first surface (S1) and is imaged in the vicinity of the vertex of the second surface (S2).

Aberrations can also reliably be corrected when the first surface (S1) or the second surface (S2) is a plane surface, as in the fifth to the seventh embodiments. This structure is advantageous in manufacture because decentration is small.  
10 When the second surface (S2) is a plane surface and the first surface (S1) is a high-refractive-index surface, as in the fifth embodiment, the angle of the marginal ray increases. Therefore, this structure is advantageous when it is necessary to maximize the resolution. When the first surface (S1) is a plane surface, as in the sixth and the seventh embodiments, incident collimated light is not refracted at the  
15 first surface (S1), so that no chromatic aberration is generated. Consequently, focus shift does not occur even if the laser wavelength being used varies. In addition, lasers of a plurality of different wavelengths can be used as the light source, according to the desired application. By using a paraboloid of revolution as the second surface (S2), as in the seventh embodiment, or by using an  
20 aspherical surface close to a paraboloid of revolution as the second surface (S2), a so-called stigmatic lens can be obtained.

The eighth embodiment of Figure 15 is a pickup lens in which the first surface (S1) is a concave spherical surface and the second surface (S2) is a convex aspherical surface. The ninth embodiment of Figure 17 is a pickup lens in which  
25 the first surface (S1) is a concave aspherical surface and the second surface (S2) is a convex spherical surface. In the structures of the eighth and the ninth embodiments, where the first surface (S1) is concave to the long conjugate distance side and the second surface (S2) is strongly convex to the side opposite to the long conjugate distance side, in order of disposal from the long conjugate distance side,

the luminous flux passing through a peripheral part of the first surface (S1) is reflected at a peripheral part of the second surface (S2), is again reflected at a central part of the first surface (S1), and is imaged in the vicinity of the vertex of the second surface (S2).

5           At first glance, the configurations of the eighth and the ninth embodiments seem disadvantageous for aberration correction. However, since the light converted into weak divergent light by the first surface (S1) is strongly converged by the second surface (S2), it is easy to correct spherical aberration. Moreover, since the first surface (S1) is a weak concave surface and a ray being angled  
10           outward is reflected at the second surface (S2), the width of the luminous flux reflected again at the first surface (S1) is smaller than that of the luminous flux incident on the first surface (S1). Consequently, the area of the totally reflecting coating on the first surface (S1) (the hatched part in Figure 19) can be reduced, so that the light quantity loss decreases.

15           By using an aspherical surface for one of the surfaces, as in the eighth and the ninth embodiments, the wavefront aberration can be reliably corrected to  $\lambda/8$  or less. Moreover, by decreasing the aberration correction burden on each surface, by using aspherical surfaces for both of the surfaces, the numerical aperture can be increased. Therefore, by decreasing the beam spot diameter,  
20           higher-density optical recording can be handled.

          In all of these embodiments, by providing the SIM structure in which the luminous flux passing through a peripheral part of the first surface (S1) is reflected at a peripheral part of the second surface (S2), is again reflected at a central part of the first surface (S1) and is imaged in the vicinity of the vertex of the second  
25           surface (S2), a simple configuration formed of only the two surfaces (S1, S2) of a continuous configuration and suitable for glass molding is achieved. For this reason, the embodiments are easily manufactured by glass molding using a high-refractive-index glass material and are advantageous in light quantity. Moreover, there are merits such that the weight of the head portion does not increase since the

embodiments are formed of one lens element, and the condensed light spot decreases since the SIL structure performing in-lens imaging is provided. It is to be noted that the present invention is applicable not only to systems in which the light emitted from the light source is applied to an optical recording medium, but also to systems in which divergent light of the light applied to a recording medium from another system is received by a light receiving element.

Hereinafter, reflecting microoptical systems embodying the present invention will be described in more detail by providing construction data and graphic representations of aberrations. The first to ninth examples discussed below correspond to the above-described first to ninth embodiments. The lens construction views showing the first to the ninth embodiments (Figures 1, 3, 5, 7, 9, 11, 13, 15 and 17) show the lens constructions of the corresponding first to ninth examples. Figures 2, 4, 6, 8, 10, 12, 14, 16 and 18 show spherical aberrations of the first to the ninth examples.

In the construction data of the examples,  $S_i$  ( $i=1, 2$ ) represents the  $i$ -th surface counted from the long conjugate distance side,  $r_i$  represents the radius of curvature of the surface  $S_i$ ,  $d$  represents the thickness (axial distance) of the lens, and  $N$  represents the refractive index of the lens. The surfaces  $S_i$  marked with asterisks are aspherical. When the optical axis (AX) is the  $x$ -axis, the  $y$ -axis is within a plane perpendicular to the optical axis (AX) and the vertex is the point of origin, the aspherical surfaces are defined by the expression (AS) shown below. The wavelength  $\lambda$  of the ray being used, the numerical aperture NA, the focal length  $fL$  and the aspherical data of the aspherical surfaces are also shown.

$$x = (C \cdot y^2) / \{1 + \sqrt{1 - \epsilon \cdot C^2 \cdot y^2}\} + \sum (A_i \cdot y^i) \quad \dots (AS)$$

where  $x$  is the amount of displacement from the reference surface in the direction of the optical axis (AX) at a height  $y$ ,  $y$  is the height in a direction perpendicular to the optical axis (AX),  $C$  is the curvature at the vertex,  $\epsilon$  is the conic constant, and  $A_i$  is the  $i$ -th aspherical coefficient.

**a**

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S1\*                    r1 = 3.80245

S2\*                    r2 = -16.95438

$$\epsilon = 1.000000000$$

10

$$A8 = -0.36085168 \times 10^{-3}$$
$$A_{10} = -0.31090594 \times 10^{-3}$$
$$\epsilon = 1.000000000$$

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$$A4 = 0.29258470 \times 10^{-2}$$
$$A6 = 0.15051402 \times 10^{-4}$$
$$A8 = -0.26476511 \times 10^{-3}$$
$$A_{10} = -0.20066942 \times 10^{-3}$$

## 20

(surface) (radius of curvature) (Axial Distance) (refractive index)

S1\*      r1 = 3.81254

$$d = 1.12694 \quad N = 1.83375$$

S2\*      r2 = -16.71558

25

Aspherical coefficient of the first surface (S1)

$$\epsilon = 1.000000000$$
$$A4 = 0.70512314 \times 10^{-3}$$
$$A6 = -0.61423621 \times 10^{-3}$$



$$A8 = -0.58788514 \times 10^{-3}$$

$$A10 = -0.86000992 \times 10^{-3}$$

Aspherical coefficient of the second surface (S2)

$$\epsilon = 1.00000000$$

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$$A4 = 0.43189895 \times 10^{-2}$$

$$A6 = -0.56153643 \times 10^{-4}$$

$$A8 = -0.13130585 \times 10^{-2}$$

$$A10 = 0.19684362 \times 10^{-4}$$

### 3rd embodiment

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$$\lambda = 680 \text{ nm}, NA = 0.545 \text{ (in air)}, fL = 1.834$$

(surface) (radius of curvature) (Axial Distance) (refractive index)

$$S1^* \quad r1 = 3.80058$$

$$d = 1.12844 \quad N = 1.83375$$

$$S2 \quad r2 = -16.97581$$

15

Aspherical coefficient of the first surface (S1)

$$\epsilon = 1.00000000$$

$$A4 = -0.56964867 \times 10^{-2}$$

$$A6 = -0.72642979 \times 10^{-3}$$

$$A8 = 0.48513914 \times 10^{-4}$$

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$$A10 = 0.23077580 \times 10^{-3}$$

### 4th embodiment

$$\lambda = 680 \text{ nm}, NA = 0.545 \text{ (in air)}, fL = 1.852$$

(surface) (radius of curvature) (Axial Distance) (refractive index)

$$S1 \quad r1 = 3.94291$$

25

$$d = 1.12794 \quad N = 1.83375$$

$$S2^* \quad r2 = -15.05560$$

Aspherical coefficient of the second surface (S2)



$$A8 = 0.48985589 \times 10^{-4}$$

$$A10 = -0.19239174 \times 10^{-4}$$

### 7th embodiment

$$\lambda = 680 \text{ nm}, NA = 0.667 \text{ (in air)}, fL = 3.000$$

5 (surface) (radius of curvature) (Axial Distance) (refractive index)

$$S1 \quad r1 = \infty$$

$$d = 1.50000 \quad N = 1.83375$$

$$S2^* \quad r2 = -6.00000$$

Aspherical coefficient of the second surface (S2)

$$10 \quad \epsilon = 1.00000000$$

$$A4 = 0.57870093 \times 10^{-3}$$

$$A6 = 0.80424469 \times 10^{-5}$$

$$A8 = 0.13660248 \times 10^{-6}$$

$$A10 = 0.34335882 \times 10^{-8}$$

### 15 8th embodiment

$$\lambda = 680 \text{ nm}, NA = 0.545 \text{ (in air)}, fL = 2.270$$

(surface) (radius of curvature) (Axial Distance) (refractive index)

$$S1 \quad r1 = -100.87631$$

$$d = 1.12794 \quad N = 1.83375$$

$$20 \quad S2^* \quad r2 = -4.41934$$

Aspherical coefficient of the second surface (S2)

$$\epsilon = 1.00000000$$

$$A4 = 0.12921255 \times 10^{-2}$$

$$A6 = 0.14705320 \times 10^{-4}$$

$$25 \quad A8 = 0.48466904 \times 10^{-4}$$

$$A10 = -0.16958548 \times 10^{-4}$$

**9th embodiment**

$\lambda = 680 \text{ nm}$ ,  $\text{NA} = 0.558$  (in air),  $fL = 2.217$

(surface) (radius of curvature) (Axial Distance) (refractive index)

S1\*  $r1 = 314.51013$

5

$d = 1.11024$   $N = 1.83375$

S2  $r2 = -4.47227$

Aspherical coefficient of the first surface (S1)

$\epsilon = 1.00000000$

$A4 = -0.48519953 \times 10^{-2}$

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$A6 = 0.24538094 \times 10^{-3}$

$A8 = -0.11191141 \times 10^{-3}$

$A10 = 0.44340458 \times 10^{-4}$

According to the above-described examples, a reflecting microoptical system can be realized that is formed of only two surfaces of a continuous configuration, and has a simple configuration suitable for glass molding.

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It will be appreciated by those of ordinary skill in the art that the present invention can be embodied in other specific forms without departing from the spirit or essential characteristics thereof. The presently disclosed embodiments are therefore considered in all respects to be illustrative, and not restrictive. The scope of the invention is indicated by the appended claims, rather than the foregoing description, and all changes that come within the meaning and range of equivalents thereof are intended to be embraced therein.

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